



Attorney Docket No. 0756-7289

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/820,781

Filed: April 9, 2004

For: BEAM IRRADIATION APPARATUS,
BEAM IRRADIATION METHOD, AND
METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit: 2812

) Examiner: S. Isaac

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
) being deposited with the United States Postal
) Service with sufficient postage as First Class
) Mail in an envelope addressed to:
) Commissioner for Patents, P.O. Box 1450,
) Alexandria, VA 22313-1450, on August 29,
) 2005.

) Adelle M. Stamps

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 9 of this paper.